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# Self-assembled and Pd decorated Zn<sub>2</sub>SnO<sub>4</sub>/ZnO wire-sheet shape nano-heterostructures networks hydrogen gas sensors



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# ABSTRACT

Zn<sub>2</sub>SnO<sub>4</sub>/ZnO wire-sheet shape hetero-nanostructures (Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS) networks gas sensors have been fabricated on Cr comb-shaped interdigitating electrodes with relatively narrower interspace of 1.5 µm using thermal evaporation of the mixed powders of ZnO, SnO<sub>2</sub> and active carbon with Au catalysts. The self-assembly grown sensors of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks have excellent gas sensing characteristics to hydrogen concentration ranging from 2 to 1000 ppm at operating temperature of 120–300 °C. Comparing with Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors, the Pd decorated Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS (Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS) networks sensors exhibit enhanced hydrogen sensing performance such as higher response (74% at 255 °C to 1000 ppm H<sub>2</sub>), less response time (15 s at 270 °C to 1000 ppm H<sub>2</sub>), better selectivity (response to H<sub>2</sub>, C<sub>2</sub>H<sub>5</sub>OH, CH<sub>4</sub>, C<sub>2</sub>H<sub>2</sub>, CO, and C<sub>3</sub>H<sub>8</sub>), lower adsorption activation energy (12.72 kJ/mol to 1000 ppm H<sub>2</sub>) and smaller deviation from the ideal value of power exponent  $\beta$  (0.49623 at 255 °C). The enhanced sensing properties of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS can be ascribed to an additional depletion layer at the interface between Pd nanoparticles and Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. Both sensors show fine long-term stability during exposure to 2–1000 ppm H<sub>2</sub> under relatively high operating temperature of 120–300 °C in 50 days.

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## 1. Introduction

1D nano-heterostructures consisting of different materials may combine the different physical or chemical properties into one structure. Moreover, due to the formation of the heterojunction between different materials with various band gaps, the nano-heterostructures are expected to possess some novel electric and optical properties [1]. Recently, significant progress has been made in regard to synthesis of various axial, radial and branched 1D nano-heterostructure. However, reports on the synthesis of 1D nano-heterostructures composited with two kinds of direct wide-band-gap semiconductor of  $Zn_2SnO_4$  with a band

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gap of about 3.6 eV and ZnO with a large exciton binding energy of 60 meV are very limited [2,3]. In this contribution, we report that a new  $Zn_2SnO_4/ZnO$  wire-sheet shape hetero-nanostructures ( $Zn_2SnO_4/ZnO$  HNS) have been synthesized via thermal evaporation and condensation with Au catalysts.

The ZnO nanostructures have been considered as ideal building blocks for high responsive gas sensor to detect  $O_2$ ,  $H_2$ ,  $C_2H_5OH$ , CO, and so on [4–7]. In addition,  $Zn_2SnO_4$  has also been studied for the applications as gas sensors to detect  $i-C_4H_{10}$ ,  $NO_2$ ,  $C_2H_5OH$ , CO and  $H_2$  [8–12]. Considering scarce of reports being about gas sensing properties of  $Zn_2SnO_4/ZnO$  HNS, we report the self-assembly of good selective, highly sensitive and fast responsive  $H_2$  sensors of  $Zn_2SnO_4/ZnO$  HNS networks on Cr comb-shape interdigitating electrodes with relatively narrower interspace of 1.5  $\mu$ m for the hydrogen concentration ranging from 2 to 1000 ppm.

For metal-oxide semiconductor nanostructures, the activity of gas sensing performance is usually promoted by means of decoration with catalytic noble metals such as Pd [13–15], Pt [16], Au [17], etc. Besides, Pd has been commonly used as H<sub>2</sub> sensing material with high response and selectivity because of its high H<sub>2</sub> solubility [15]. Hence, decorating  $Zn_2SnO_4/ZnO$  HNS networks with Pd nanoparticles is expected to harvest a high-performance H<sub>2</sub> gas

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sensor. However, the corresponding reports have been scarce up to now. In this contribution, we report that  $Zn_2SnO_4/ZnO$  HNS decorated with Pd nanoparticles (Pd- $Zn_2SnO_4/ZnO$  HNS) networks sensors have enhanced H<sub>2</sub> sensing performance comparing with the  $Zn_2SnO_4/ZnO$  HNS networks sensors.

#### 2. Experimental details

The self-assembly of  $Zn_2SnO_4/ZnO$  HNS hydrogen sensors includes two parts. One is the preparation of comb-shape interdigitating electrodes with relatively narrower interspace of 1.5  $\mu$ m on the Si substrate as shown in Fig. 1a, and the corresponding processes are basically same with our previous works [18].

Another part is the fabrication of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS on the Si substrate with the comb-shaped interdigitating electrodes by themetallic catalyst-assisted thermal evaporation of active carbon, ZnO and SnO<sub>2</sub> powders. The Au layer (about 5 nm in thickness) is deposited on Si substrate with the electrodes by sputtering. The active carbon, ZnO and SnO<sub>2</sub> powders are mixed in a 3:2:1 weight ratio as the reaction source and put near the Si substrate with the electrodes, which are placed inside the little guartz tube that is pulled into a large quartz tube in a horizontal tube electric furnace. After the whole system evacuated by a vacuum pump for 20 min, the N<sub>2</sub> gas is guided into the system at 50 sccm and the pressure is kept at 300 Torr. Then, the system is rapidly heated up to 800 °C from the room temperature and kept this temperature for 10 min. Finally, the system is cooled down to the room temperature in several hours. The Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS gas sensor chip shown in Fig. 1b is fabricated. Field-emission scanning electron microscopy (FE-SEM, Hitachi/SU-70) and high-resolution transmission electron microscopy (HR-TEM, Jeol/JEM-2010) are used to identify the morphology and structure of the products. The function of the active carbon in the thermal evaporation is to serve as a reducing agent, so as to obtain Sn and Zn vapor sources [19].

After the growth of  $Zn_2SnO_4/ZnO$  HNS on Cr comb-shape interdigitating electrodes, we coated a thin layer of Pd onto the surface of  $Zn_2SnO_4/ZnO$  HNS by sputtering. The sputter current is 2 mA, and the deposition time is 300 s.

The heater of the gas sensor and the corresponding 3D schematic diagram are shown in Fig. 1c and d, respectively. The heater steel silks on the thermal insulation material are connected with the metal pins "1" and "4". Each gas sensor chip is put on the heater steel silks and bonded to another two metal pins so as to constitute sensor element as shown in Fig. 1e, and the corresponding 3D schematic diagram is show in Fig. 1f. When the heating voltage is applied to metal pins "1" and "4", the temperature of the heater steel silks will rise up according to Joule's law so as to make the temperature of gas sensor chip rise up. When the bias voltage is applied to metal pins "3" and "6", the electrical signal measurement for the gas sensor can be carried out. The sensor temperature at different heating voltage is measured by contacting a thermocouple to the upper side of gas sensor chip.

Each sensor element is packaged with a stainless steel mesh cap as shown in Fig. 1g. After that, the six metal pins of each sensor element are inserted the corresponding holes of one measurement unit in the test gas chamber as shown in Fig. 1h. There are ten measurement units in the test gas chamber, so 10 sensor elements can be tested at the same time. Then, the test gas chamber is sealed. By controlling gas-sensing characterization system (Gyjf Technology Co. Ltd., PR China/JFO2E) consisting of gas mixer instrument, measurement instrument and computer as show in Fig. 1i, certain concentration gas is passed into the test gas chamber based on a flow-through technique [20]. At the same time, >bias voltage of 8.9 V and certain heating voltage in the range of 3–6 V are supplied to test gas chamber so as to apply to each tested sensor element.

#### 3. Results and discussions

The high magnified FESEM images of the comb-shape interdigitating Cr electrodes, the prepared  $Zn_2SnO_4/ZnO$  HNS distributing on the electrodes and the morphology of several  $Zn_2SnO_4/ZnO$  HNS are shown in Fig. 1j, k and l, respectively. The interspace between electrodes is 1.5 µm and the width of the electrode is 5 µm. In the  $Zn_2SnO_4/ZnO$  HNS, the width of the nanowires is about 20–30 nm, the side length and the thickness of the hexagon nanosheets are about 50 nm and 5 nm, respectively.  $Zn_2SnO_4/ZnO$  HNS overlap each other and form a networks structure, and such HNS networks provide large surface area in 3D space. Compared to the pressed nanograin thin film, in which only surface of the upper layer can be exposed to gas species, the HNS networks can, in principle, expose all the surface of each nanostructure to tested gas [21].

The morphology and structure of the as-synthesized Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS samples are analyzed in detail by HRTEM in Fig. 2. The typical TEM bright-field images of some  $Zn_2SnO_4/ZnO$ HNS and an individual Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS are shown in Fig. 2a and b, respectively. The corresponding EDS spectra in Fig. 2c show that the HNS in Fig. 2b is composed of O, Zn, Sn and Au. In addition, Cu and C are from the Cu net and C thin film in the process of TEM, respectively. The EDS elemental mappings in Fig. 2d-g show that element O and Zn distribute mainly in the nanosheet and slightly in the nanowire, element Sn distributes mainly in the nanowire, and element Au distributes mainly in the nanosheet as the catalyst according to the VLS mechanism in the process of nanostructures growth [22]. To be sure, in Fig. 2d-g, the x- and y-axes are added to accurately locate the position of the nanosheet so as to ascertain the existence area of every element in the HNS. Fig. 2h is a part and further magnified TEM bright-field image in Fig. 2b. In Fig. 2i, the HRTEM image recorded at the junction of nanowire and the nanosheet in the red frame in Fig. 2h shows that the interplanar spacing of 0.502 nm is corresponding to the (111)crystallographic plane of cubic Zn<sub>2</sub>SnO<sub>4</sub> lattice, and the interplanar spacing of 0.248 nm is corresponding to the (101) crystallographic plane of hexagonal ZnO lattice. The corresponding fast Fourier transforms of the HRTEM image for Zn<sub>2</sub>SnO<sub>4</sub>, ZnO and the interface of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO are shown in Fig. 2j, 2k and 2l, respectively. The fast Fourier transform in Fig. 21 comprises of two sets of patterns that are identified to be the cubic Zn<sub>2</sub>SnO<sub>4</sub> structure (fast Fourier transforms in Fig. 2j) and hexagonal wurtzite ZnO structure (fast Fourier transforms in Fig. 2k), respectively. Above all, the nanowire is Zn<sub>2</sub>SnO<sub>4</sub> and the nanosheet is ZnO in the HNS.

The morphology and structure of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS are analyzed by HRTEM in Fig. 3. The whole Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS is covered by numerous Pd nanoparticles with the size of 6–9 nm as shown in Fig. 3a. The corresponding EDS spectra in Fig. 3b show that the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS is composed of O, Zn, Sn, Au and Pd. The EDS elemental mappings in Fig. 3c–f show that the distributions of element O, Zn Sn and Au are same with those of the results in Fig. 2d–g, which is corresponding with the conclusions resulting from Fig. 2h–1 that the nanowire is Zn<sub>2</sub>SnO<sub>4</sub> and the nanosheet is ZnO in the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. Besides, the EDS elemental mapping in Fig. 3g shows that element Pd distributes in the whole Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS, which is corresponding with the image shown in Fig. 3a. The amount of deposited Pd nanoparticles in the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS is 1 wt%.

H<sub>2</sub> sensing characteristics are investigated when the sensors are exposed to different H<sub>2</sub> concentration of 2–1000 ppm, and operated at different heating voltage of 3 V, 4 V, 4.8 V, 5 V, and 6 V, corresponding to different substrate temperature of 120 °C, 200 °C, 255 °C, 270 °C, and 300 °C, respectively. The responses of the two kinds of sensors are shown in Fig. 4a and b, respectively. We calculated the response (relative resistance change) of the sensor using the expression of Response% =  $(R_0 - R_g)/R_0 \times 100\%$  [23]. Here



**Fig. 1.** The sensor element and gas-sensing characterization system: (a) comb-shape interdigitating Cr electrodes on the Si substrate; (b)  $Zn_2SnO_4/ZnO$  HNS gas sensor chip; (c) the heater of the gas sensor; (d) the 3D schematic diagram of the heater; (e) the sensor element; (f) the 3D schematic diagram of the sensor element; (g) sensor element packaged with a stainless steel mesh cap; (h) test gas chamber; (i) measurement instrument, gas mixer instrument and computer; the high magnified FESEM images of (j) the comb-shaped interdigitating Cr electrodes, (k) the prepared  $Zn_2SnO_4/ZnO$  HNS distributing on the electrodes and (l) the morphology of several  $Zn_2SnO_4/ZnO$  HNS.

 $R_{\rm o}$  and  $R_{\rm g}$  are the resistance of the sensor before and in exposing to the tested gas, respectively. The responses of the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor are lower than those of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor at every same concentration and same operating temperature. Fig. 4c and d shows the response as a function

of operating temperature from 120 to  $300 \,^{\circ}$ C for two devices exposed to 2–1000 ppm H<sub>2</sub>. Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor reaches the maximum response value of 46% at optimal operating temperature of 270  $^{\circ}$ C, while Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor reaches the maximum response value of 74% at optimal



**Fig. 2.** The HRTEM characterized results of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS: >the >TEM bright-field images of (a) some Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS and (b) an individual Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS; (c) the EDS spectra, (d-g) the EDS elemental mappings, and (h) the part and further magnified TEM bright-field image of the single Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS; (i) the HRTEM image of the interface of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO; fast Fourier transforms of the HRTEM image for (j) the Zn<sub>2</sub>SnO<sub>4</sub>, (k) the ZnO and (l) the interface of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO.



Fig. 3. The HRTEM characterized results of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS: >(a) the high magnified TEM bright-field image, (b) the EDS spectra, (c-g) the EDS elemental mappings of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS.

operating temperature of 255 °C. By contrast, Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor results in higher response and lower optimal operating temperature to  $H_2$ .

The steady-state resistance response of the two kinds of sensors during exposure to increasing H<sub>2</sub> concentrations (between 2 and 1000 ppm) under respective optimal operating temperature of 255 °C or 270 °C is also investigated in Fig. 5a. According to the Zhu et al. [21], this should be done in a stable environment; and the time of measurement should be long enough to insure adsorption of hydrogen molecules to reach steady-state. Fig. 5b shows that the corresponding steady-state conductance (G = 1/R) of the two kinds of sensors follows a power law dependence on the H<sub>2</sub> gas concentration,  $G_{gas} = G_{air} + \alpha (\text{concentration})^{\beta}$ , where  $\alpha$  is a constant,  $\beta$  is

a power exponent [24]. By further derived based on the dynamic theory [25],  $\alpha = e_0 \mu \lambda (\xi/\eta)^{1/2}$ . Where, the proportionality constant  $\xi$  is dimensionless and plays the role of a sticking or reaction coefficient; the proportionality constant  $\eta$  (cm<sup>2</sup>/s) is the surface recombination coefficient which has an Arrhenius temperature dependence;  $\lambda$  is the sensor layer thickness,  $e_0$  is the electronic charge magnitude, and  $\mu$  is the electronic mobility. Variation of the microstructure can also change, sometimes dramatically, the relative values of  $\alpha$  for different gases. Different  $\alpha$  to variations in microstructure focuses attention on ways of obtaining controlled, reproducible, and regular microstructures with the critical dimensions commensurate with the Debye length of the oxide [26]. In addition, the  $\beta$  has some rational fraction value (usually 1 or



**Fig. 4.** Typical response curves of (a) Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor and (b) Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor exposed to H<sub>2</sub> concentrations ranging from 2 to 1000 ppm and tested at 120 °C, 200 °C, 255 °C, 270 °C, 300 °C, respectively; the response as a function of operating temperature of 120–300 °C exposed to 2–1000 ppm H<sub>2</sub> for (c) Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor and (d) Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor.

1/2), dependent on the charge of the surface species and the stoichiometry of the elementary reactions on the exterior. While the measurements often do give such rational values for the response exponent, non-rational values, different for different preparations of a given material in response to a given gas, are also frequently seen [26]. Studies of thin films imply that the response exponent for SnO<sub>2</sub>, ZnO or Zn<sub>2</sub>SnO<sub>4</sub>, free of effects due to the microstructure, is  $\beta = 0.5$  [25]. The expected response exponent for an "ideal" microstructure is  $\beta = 0.5$  [24,26]. The effect of randomness in the microstructure is expected to be an increase of  $\beta$  above this value, and of agglomeration or of zones of the structure that are less gas sensitive than others is expected to be a decrease of  $\beta$  below this value [26]. The experimental data deduced from the measurement results in Fig. 5a are well consistent with the exponent fitting results, and the corresponding  $\alpha$ ,  $\beta$ , correlation coefficient R values obtained in the process of fitting are indicated in Fig. 5b. The somewhat difference between two  $\alpha$  values of  $1.22793 \times 10^{-6}$  and  $1.88408 \times 10^{-6}$  is mainly due to different surface structures of two kinds of sensors [26]. For the  $\beta$  value of 0.39171 or 0.49623, the small deviations from the ideal value of 0.5 probably relate to either agglomeration or zones in the structure that are less sensitive to H<sub>2</sub> than others, as modeled recently by Scott et al. [26].

Response time is also an important parameter for a gas sensor, which are defined here as the time to reach 90% of the final equilibrium value [27]. The corresponding response times of the two kinds of sensors exposed to  $H_2$  concentration of 2–1000 ppm at the

operating temperature of 120°C and 270°C are indicated in Fig. 6a–d. The response times of the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor are larger than those of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor at the same concentration and at the same operating temperature. The response time with respect to H<sub>2</sub> concentration of two kinds of sensors at the operating temperature of 120°C and 270 °C are shown in Fig. 6e and f, respectively. The reciprocal of the response time shows basically a linear relationship with H<sub>2</sub> concentration, and the reason is explained as follows. According to the Langmuir adsorption isotherm theory, in the case of the dissociation of a molecule into two species (H<sub>2</sub> into 2H), the process of adsorption is considered to be a reaction between the gas molecule and two surface sites [23]. At equilibrium (when the adsorption/desorption rates are equal), the relationship between the surface fraction occupied by adsorbates  $(\Theta)$  and the pressure (P) or concentration of gas molecules is expressed as:  $K_a \cdot P \cdot$  $(1-\Theta)^2 = K_d \cdot \Theta^2$ , or  $\Theta/(1-\Theta) = (K \cdot P)^{1/2}$ . Where the equilibrium constant (K) is defined by  $k_a/k_d$ , and  $k_a/k_d$  denote the adsorption/desorption rate constants, respectively. At the initial stage of the measurement, the rate of H<sub>2</sub> adsorption is  $K_a \cdot P \cdot (1 - \Theta)^2$ , where  $(1 - \Theta)^2$  indicates the fraction of surface that is not covered by  $H_2$ . Since  $\Theta$  is negligible at the initial stage, the adsorption rate is approximately  $r \sim K_a \cdot P$ . That is to say, initial H<sub>2</sub> adsorption rate follows a linear relationship with H<sub>2</sub> concentration. Moreover, the reciprocal of the response time is corresponding to the initial H<sub>2</sub> adsorption rate [23], so the reciprocal of the response time shows

Hydrogen sensing characteristics of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor operated at 255 °C and Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor operated at 270 °C in comparison to those of the reported sensors using nanostructured materials I

Type	Operated temperature	Response	e ( $\Delta R/R_{ m o}  imes 100\%$ )	toward H <sub>2</sub> under t	he following concer	itrations (ppm)			Response time (s) to
	(°C)	2	10-50	50-270	400-500	1000	10,000	40,000	150–270 ppm H <sub>2</sub>
Pd-Zn <sub>2</sub> SnO <sub>4</sub> /ZnO HNS	255	10	20	40	60	75	I	I	25
Zn <sub>2</sub> SnO <sub>4</sub> /ZnO HNS	270	00	15	28	38	47	I	I	29
Pt-W <sub>18</sub> O <sub>49</sub> nanowires [21]	200	I	11.9	26.7	41.6	52.8	I	I	60
SnO <sub>2</sub> nanowire [30]	350	I	I	5	I	I	I	I	153
Pd-ZnO nanorods [28]	20-25	I	2.6	3.9	4.2	I	I	I	300-420
Pd-Ga nanowires [29]	20-25	I	I	7.4	8.3	8.6	ı	I	300-420
Pt-SnO <sub>2</sub> nanowire [31]	200	I	I	I	I	ı	50	I	<40
Single Pd nanowire [32]	20-25	I	I	I	I	I	I	8	120-600
ZnO nanorods [33]	20-25	I	4.2	5.5	7.6	I	I	I	600
ZnO/In2O3 nanorods [33]	20-25	I	9.8	15.5	20.5	I	I	I	400
Pt-InN nanowires [34]	20-25	I	2	3.1	I	I	I	I	300-420
Pt-GaN nanowires [35]	25	I	I	1.7	1.7	I	I	I	600
In <sub>2</sub> O <sub>3</sub> nanowires [36]	200	I	I	17	60	ı	I	I	31
In <sub>2</sub> O <sub>3</sub> nanoneedles [36]	200	I	I	10.7	20	ı	ı	I	60
Pd-GaN nanowires [37]	25	I	I	12	13	14	I	I	30
Pd-InN nanobelts [37]	130	I	I	8	6	9.5	I	I	300
Pt-InN nanorods [37]	25	I	I	11	I	I	I	I	300
Pt-ZnO nanorods [37]	25	I	I	I	8	I	I	I	600
SnO <sub>2</sub> /carbon nanotubes [38]	100	I	I	23	28.6	37.5	ı	ı	500



**Fig. 5.** (a) The steady-state resistance responses of two kinds of sensors during exposure to increasing  $H_2$  concentrations (between 2 and 1000 ppm) under respective optimal operating temperature of 255 °C or 270 °C; (b) the corresponding steady-state conductance of both sensors as a function of the  $H_2$  concentration.

basically a linear relationship with  $H_2$  concentration as shown in Fig. 6e and f, which indicates that the sensing kinetics of the sensors mainly relied on the hydrogen dissociation process.

The time dependent of resistance of the  $Zn_2SnO_4/ZnO$  HNS networks and Pd- $Zn_2SnO_4/ZnO$  HNS networks on exposure to 1000 ppm of H<sub>2</sub> at different operating temperature of 120–300 °C, are shown in Fig. 7a and b, respectively. The rate of resistance change becomes greater as temperature increases. The inset figures show the Arrhenius plot of rate of heterostructures resistance change. An adsorption activation energy of 14.98 kJ/mol for the  $Zn_2SnO_4/ZnO$  HNS networks as shown in Fig. 7a is larger than that of 12.72 kJ/mol for the Pd- $Zn_2SnO_4/ZnO$  HNS networks as shown in Fig. 7b, that of 11.8 kJ/mol for the Pd-coated ZnO nanowires [28] and that of 2.2 kCal/mol for the Pd-coated GaN nanowires [29], but lower than that of 23.6 KJ/mol for the Pt-coated W<sub>18</sub>O<sub>49</sub> nanowire networks [21].

The repeatability for  $H_2$  (2 ppm, 10 ppm, 100 ppm, 1000 ppm) sensing at the operating temperature of 270 °C for the two kinds of sensors are shown in Fig. 8a and b, respectively. The response and recovery characteristics are repeatable when the sensing element is switched back and forth between air and  $H_2$  gas environment.

Selectivity is one of the basic properties of gas sensor. The selectivity properties of the two kinds of sensors are tested within reducing gases such as CH<sub>4</sub>, C<sub>3</sub>H<sub>8</sub>, C<sub>2</sub>H<sub>2</sub>, CO, C<sub>2</sub>H<sub>5</sub>OH, H<sub>2</sub>, at the



**Fig. 6.** One cycle of H<sub>2</sub> in and out in the concentration range of 2–1000 ppm under different operating temperature of 120 °C and 270 °C for (a), (b) Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor and (c), (d) Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor; the response time with respect to H<sub>2</sub> concentration of the two kinds of sensors at the different operating temperature of (e) 120 °C and (f) 270 °C.

concentration of 10 ppm, 100 ppm, 1000 ppm, under the different operating temperature of  $120 \,^{\circ}C$  (Fig. 9a) and  $270 \,^{\circ}C$  (Fig. 9b), respectively. It is very clear to discover that two kinds of sensors exhibit higher responses to H<sub>2</sub> in comparison with other gases, which indicates that both sensors have good selectivity properties. In addition, the responses of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors to H<sub>2</sub> are higher than those of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors at the same concentration and at the same operating temperature, so the selectivity of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors to H<sub>2</sub> is better than that of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors due to high H<sub>2</sub> solubility of Pd [15].

Considering the high operating temperature in the process of measurement possibly leading to the short life time, the longterm stability of the two kinds of sensors are also determined as shown in Fig. 10a and b, respectively. Clearly, the sensors show stable responses to 2–1000 ppm H<sub>2</sub> at operating temperature of 120–300  $^{\circ}$ C in 50 days, which confirms the high stability of the sensors at relatively high operating temperature.

 $H_2$  sensing characteristics of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor operated at 255°C and Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor operated at 270°C in comparison to those of the reported sensors using nanostructured materials are shown in Table 1. The range of the responses of all the sensors normalized to  $(R_0 - R_g)/R_0 \times 100\%$  is from 0% to 100% due to  $R_g$  smaller than  $R_0$  and greater than zero. Thus, these results definitely show that the selfassembly Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor and Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor have basically achieved better responses than those of the reported sensors [21,28–38]. In addition, the response times of the two kinds of sensors to 150–270 ppm H<sub>2</sub> are less than those of the reported sensors [21,28–38].



**Fig. 7.** Resistance vs. time on exposure to 1000 ppm of H<sub>2</sub> under different operating temperature of 120-300°C from (a)  $Zn_2SnO_4/ZnO$  HNS networks sensor and (b) Pd- $Zn_2SnO_4/ZnO$  HNS networks sensor, the inset figures showing the corresponding Arrhenius plot based on the rates of change of the resistance.

The H<sub>2</sub> sensing mechanism of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS investigated in this study is schematically described as follows. When the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS are exposed to air, the adsorbed oxygen molecules trapping electrons at the surface result in the presence of a depletion region in surface layer and narrow the conduction channels in the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. In Zn<sub>2</sub>SnO<sub>4</sub> nanowires or ZnO nanosheets, free carriers (electrons) can transport along the conduction channel. But when transporting between the overlapping  $Zn_2SnO_4/ZnO$  HNS, the electrons have to pass through potential barrier at the junctions and a thermoelectronic emission mechanism can be used to describe the electron transportation in the junctions [21]. In this paper, the overlapping  $Zn_2SnO_4/ZnO$  HNS affecting the electron transportation in the networked junctions can be summarized as three modes: the contact between two Zn<sub>2</sub>SnO<sub>4</sub> nanowires, the contact between one Zn<sub>2</sub>SnO<sub>4</sub> nanowire and one ZnO nanosheet, the contact between two ZnO nanosheets. The schematic illustration accounting for the three mechanisms operated in the networked HNS and the corresponding energy band diagram are shown in Fig. 11a.  $E_{vac}$ ,  $E_c$ ,  $E_v$ , and  $E_F$  are abbreviations of vacuum energy, conduction band minimum (CBM), valence band maximum (VBM), and Fermi level, respectively. Band gap of Zn<sub>2</sub>SnO<sub>4</sub> and ZnO are 3.6 eV [39] and 3.37 eV [40], respectively. Work function of Zn<sub>2</sub>SnO<sub>4</sub> and ZnO are 4.9eV [41] and 5.0eV [42], respectively. The change in resistance during the adsorption



**Fig. 8.** Repeatability of the H<sub>2</sub> (2 ppm, 10 ppm, 100 ppm, 1000 ppm) sensing performance at the operating temperature of  $270^{\circ}$ C from (a)  $Zn_2SnO_4/ZnO$  HNS networks sensor and (b) Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensor.

or desorption process of H<sub>2</sub> species is likely to be caused by the alteration both in the width of the surface depletion layer of each  $Zn_2SnO_4/ZnO$  HNS and in the height of potential barriers built at the networked junctions. These two-fold effects may facilitate less response time and higher response to certain chemical species [43].

The modulation of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS electrical transport properties through Pd nanoparticles is utilised to improve gas response. In the open air, the oxygen adsorbates  $(O_2^- \text{ or } O^-)$  form on the surface of Pd [44], Zn<sub>2</sub>SnO<sub>4</sub> [8] and ZnO [45] leading to a depletion region in surface layer owing to the electron shift from Pd, Zn<sub>2</sub>SnO<sub>4</sub> and ZnO to oxygen. The sensing mechanism can be described as: H<sub>2</sub> reacts with oxygen adsorbates, which release electrons back to the surface of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS and alter its electrical conductivity of the structure [45]. The corresponding schematic illustration is shown in Fig. 11b. The enhanced sensing properties of the Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS can be ascribed to an additional depletion layer at the interface between Pd nanoparticles and Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. The possible contribution is discussed as follows: The "electronic mechanism" proposes the formation of depletion zones around the particles and attributes the improved sensing to the modulation of the Schottky barrier [45]. Because the work function of Pd (5.12 eV) [44] is larger than that of  $Zn_2SnO_4$ (4.9 eV) [41] and ZnO (5.0 eV) [42], the electrons in Zn<sub>2</sub>SnO<sub>4</sub>/ZnO



**Fig. 9.** The selectivity properties of two kinds of sensors to reducing gases such as CH<sub>4</sub>, C<sub>3</sub>H<sub>8</sub>, C<sub>2</sub>H<sub>2</sub>, CO, C<sub>2</sub>H<sub>5</sub>OH, H<sub>2</sub>, at the concentration of 10 ppm, 100 ppm, 1000 ppm, and under the different operating temperature of (a) 120 °C and (b) 270 °C.

HNS will transfer to Pd, thus leading to a Schottky barrier and an additional depletion layer at the interface. The conduction channel of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS is much narrower compared with Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. The electrons are released much easily from the surface reaction back into the conduction channel at the regions close to the Pd/Zn<sub>2</sub>SnO<sub>4</sub> or Pd/ZnO interface, which greatly increases the conductivity of Pd-Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS in H<sub>2</sub>. Thus, these regions close to the Pd/Zn<sub>2</sub>SnO<sub>4</sub> or Pd/ZnO interface make sensors more active in gas detection compared with that of the surface of bare Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. Meanwhile, additional the oxygen adsorbates  $(O_2^- \text{ or } O^-)$  form on the surface of Pd nanoparticles onto Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS by taking away electrons from Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS [45]. Compared with bare Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS, the attachment of Pd nanoparticles onto Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS induces more active sites for the adsorption of oxygen molecules. Thus, these Pd regions on the surface of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS become high-performance gas sensing elements, making the sensors more active in H<sub>2</sub> detection than that of bare  $Zn_2SnO_4/ZnO$  HNS.

However, both sensors exhibit relatively low responses as compared to those reported in many previous works based on ZnO, and the reason can be possibly explained as follows: Firstly,



**Fig. 10.** Long-term stability to 2–1000 ppm H<sub>2</sub> at the operating temperature of 120–300 °C in 50 days for (a)  $Zn_2SnO_4/ZnO$  HNS networks sensor and (b) Pd- $Zn_2SnO_4/ZnO$  HNS networks sensor.

the effective surface area is not as large as predicted because the porosity (voids) of the  $Zn_2SnO_4/ZnO$  HNS is high; Secondly, for the polycrystalline of  $Zn_2SnO_4/ZnO$  HNS networks containing  $Zn_2SnO_4$  nanowire monocrystals and ZnO nanosheet monocrystals, the potential well can be formed in the ZnO nanosheets due to the barrier of the  $Zn_2SnO_4$  nanowires being higher than that of the ZnO nanosheets, for the second and the third modes as shown in Fig. 11a. Therefore, the electrons are easily confined to the potential well of ZnO nanosheets between two barriers of the  $Zn_2SnO_4$  nanowires so as to retard the electron transport through inter-grains, which can cause to a large resistance. Thirdly, for the first modes as shown in Fig. 11a, the relatively higher barrier of the  $Zn_2SnO_4$  comparing with that of the ZnO may lead to the electron transportation in the junctions of bare ZnO being easier than that in the junctions of bare Zn\_2SnO\_4, which also brings about



**Fig. 11.** (a) The schematic illustration accounting for the three mechanisms of the overlapping  $Zn_2SnO_4/ZnO$  HNS affecting the electron transportation operated in the networked HNS and the corresponding energy band diagram; (b) the schematic illustration accounting for the modulation of  $Zn_2SnO_4/ZnO$  HNS electrical transport properties through Pd nanoparticles for improving the gas response.

relatively low response of both sensors in comparison to those of many previously reported ZnO sensors.

#### 4. Conclusions

In summary, we report that new Zn<sub>2</sub>SnO<sub>4</sub>/ZnO wire-sheet shape hetero-nanostructures have been synthesized via thermal evaporation and condensation with Au catalysts. The self-assembly sensors of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks on Cr comb-shape interdigitating electrodes with relatively narrower interspace of 1.5  $\mu$ m have good selectivity, high response, low response time and adsorption

activation energy, fine repeatability and long-term stability, small deviation from ideal value of power exponent  $\beta$ , in the hydrogen concentration range of 2–1000 ppm, and at the operating temperature of 120–300 °C. The alteration both in the width of surface depletion layer of each Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS and in the height of potential barriers built at the networked junctions based on the three modes is attributed to the hydrogen sensing mechanism of Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks during the adsorption or desorption process of H<sub>2</sub> species. In addition, the Pd decorated Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors exhibit an enhanced hydrogen sensing performance comparing with the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors,

which is mainly resulting from an additional depletion layer at the interface between Pd nanoparticles and Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS. For two kinds of sensors, the correlation between the response time and hydrogen concentration is in good agreement with the Langmuir adsorption isotherm model, which indicates that the sensing kinetics of the sensors mainly relied on the hydrogen dissociation process. Comparing with the Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors, the Pd decorated Zn<sub>2</sub>SnO<sub>4</sub>/ZnO HNS networks sensors could be more promising for further practical applications.

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